



Experiment Proposal

Experiment number GP2022013

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Experiment title Elemental and surface characterization of cathodes for photoinjectors

SRF Instrument Scanning Probe Microscopes Days requested: 2

Access Route Previous GP Number: -

Science AreasMaterials, Physics, Technique DevelopmentDOI: -Sponsored GrantNoneSponsor: -

Grant Title - Grant Number: - Start Date - Finish Date: -

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Non-Technical Abstract High brightness machines, like Free Electron lasers, are driven by photoinjectors. The quality of the electron beam extracted from the source is paramount for the whole machine's

performance.

Copper cathodes are widely used, as electron sources, for their reasonable quantum efficiency, robustness, simple treatment, and implementation. However, copper cathodes, exposed to strong electric fields and continuously bombarded with high-intensity lasers, can degrade their quantum efficiency for several reasons. The most common problem is surface contamination, mainly due to carbon ions, but also thermal stress can induce dislocations inside the material that leads to extrusion, creating a tip where the electric field can grow up, leading to a dangerous discharge.

The change in quantum efficiency or, even worse, the difference in this parameter point by point can dramatically affect the beam properties, degrading the emittance and producing poor radiation source performances.

To this end, we propose performing an experiment to precisely analyze the material surface and bulk properties to understand all these features better, comparing cathodes before and after their usage inside an RF gun.

The investigation will include a technique to monitor the surface morphology, using SEM like the Tescan Vega SEM-EDX (Scanning Probe Microscope) SRF of ISIS@MACH ITALIA, to see the signature of potential damages induced by arc discharges, and with EDS to show possible surface contaminants. Also, all the instrumentation to monitor the bulk properties and lattice stress should be applied, relying on X-rays or neutrons.

Publications

Instruments Days Requested:
Access Route Previous RB Number:

Science Areas DOI:
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Grant Title Grant Number:
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Sample record sheet

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SRF Instrument Scanning Probe Microscopes

Days Requested: 2

Special requirements:

SAMPLE

Material	Cu Oxygen free 99.95%	Cu Oxygen free 99.95% not	-
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exposed to RF exposed to RF

 Formula
 Cu
 Cu

 Forms
 Solid
 Solid

 Volume
 60 cc
 60 cc

 Weight
 0.5 Kg
 0.5 mg

Weight 0.5 Kg 0.5 mg
Container or substrate - - - - - -

Storage Requirements Inert gas Inert gas

SAMPLE ENVIROMENT

Temperature Range- K- KPressure Range- mbar- mbarMagnetic field range- T- TStandard equipmentNoneNoneSpecial equipmentSample to store in inert gas-

SAFETY

Prep lab needed Yes Yes **Sample Prep Hazards** Special equip. reqs Sensitivity to air Yes Yes Sensitivity to vapour Yes Yes **Experiment Hazards Equipment Hazards Biological hazards Radioactive Hazards Additional Hazards Additional Details** Sample will be Removed By User Removed By User

